



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

PATENT APPLICATION

By Express Mail - Label No. EK 976 499 625 US

INVENTOR

John Howard Coleman,

40 Overlook Road, Locust Valley, NY 11560

TITLE

Semiconductor Fabrication and Structure for Field-Effect and Bipolar Transistor Devices

ASSISTANT COMMISSIONER FOR PATENTS WASHINGTON, D.C. 20231

SIR:

Enclosed are the following papers relating to the above-named application for patent:

15 pages of Specification with Claims and Abstract

3 sheets of Drawing(s)

2 pages of Declaration and Power of Attorney

CLAIMS AS FILED

	FILED	EXTRA	RATE (CALCULATIONS
Total Claims Independent Claims	21 - 20 = 3 - 3 =	-	× \$ 9 = × \$40 =	\$ 9
Basic Fee			TOTA	<u>\$355</u> AL \$364

The applicant qualifies for Small-Entity status.

The applicant claims priority based on his provisional application No. 60/187,290 filed March 6. 2000, entitled Method of Making New Semiconductor Material for Field Effect Transistors by Hydrogen Ion Implantation.

Please file the application and charge the applicant's Deposit Account No. 16-2080 the amount of \$364.00, to cover the filing fee. A copy of this letter is enclosed. In the event of non-payment or improper payment of a required fee, the Commissioner is authorized to charge or credit Deposit Account No. 16-2080 as required to correct the error.

Please address all correspondence to Peter A. Businger, Esq., 344 Valleyscent Avenue, Scotch Plains, NJ 07076-1170, telephone (908) 322-4835.

Respectfully,

Peter A. Businger Reg. No. 27,862

Attorney for Applicant(s)

Date: March 6, 2001

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